

Amendments to the Specification:

Please add the following new paragraph after the first paragraph ending on line 18 of page 38:

--As can be seen from Figure 16, while the wafer backside plate 2114 rotates and thus rises from the down position to assume the up position due to the centrifugal force, the sleeve 2128 does not slide or move upwardly with the wafer backside plate 2114. That is, the sliding of the wafer backside plate 2114 is independent of the vertical (i.e., non-rotational) movement of the sleeve 2128.--